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Γ	APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
	10/085,063	03/01/2002	Toshiyuki Arai	501.41261X00	9140
	20457	7590 03/25/2005		EXAMINER	
		I, TERRY, STOUT & SEVENTEENTH STRI		TRAN, BINH X	
	SUITE 1800	SEVENTEENTH STR		ART UNIT	PAPER NUMBER
	ARLINGTON	, VA 22209-3873		1765	

DATE MAILED: 03/25/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)			
	10/085,063	ARAI ET AL.			
Office Action Summary	Examiner	Art Unit			
	Binh X Tran	1765			
The MAILING DATE of this communication app	pears on the cover sheet with the c	orrespondence address			
Period for Reply					
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filled after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely. - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication. - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filled, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).					
Status					
1) Responsive to communication(s) filed on <u>06 January 2005</u> .					
2a) This action is FINAL . 2b) This action is non-final.					
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.					
Disposition of Claims					
4) Claim(s) 1-3 and 33-46 is/are pending in the application.					
4a) Of the above claim(s) is/are withdrawn from consideration.					
5) Claim(s) is/are allowed.					
6)⊠ Claim(s) <u>45 and 46</u> is/are rejected.					
7) Claim(s) is/are objected to.					
8) Claim(s) are subject to restriction and/or election requirement.					
Application Papers					
9)☐ The specification is objected to by the Examiner.					
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.					
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).					
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).					
11)☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.					
Priority under 35 U.S.C. § 119					
12)⊠ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).					
a)⊠ All b)□ Some * c)□ None of:					
1. Certified copies of the priority documents have been received.					
2. Certified copies of the priority documents have been received in Application No					
3. Copies of the certified copies of the priority documents have been received in this National Stage					
application from the International Bureau (PCT Rule 17.2(a)).					
* See the attached detailed Office action for a list of the certified copies not received.					
Attachment(s)					
1) Notice of References Cited (PTO-892)	4) Interview Summary				
Notice of Draftsperson's Patent Drawing Review (PTO-948) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date 1/6/2005.	Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:	ite atent Application (PTO-152)			
U.S. Patent and Trademark Office PTOL-326 (Rev. 1-04) Office Ac	ction Summary Pa	rt of Paper No./Mail Date 20050321			

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DETAILED ACTION

Continued Examination Under 37 CFR 1.114

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after allowance or after an Office action under *Ex Parte Quayle*, 25 USPQ 74, 453 O.G. 213 (Comm'r Pat. 1935). Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, prosecution in this application has been reopened pursuant to 37 CFR 1.114. Applicant's submission filed on 1-6-2005 has been entered.

Specification

2. The lengthy specification has not been checked to the extent necessary to determine the presence of all possible minor errors. Applicant's cooperation is requested in correcting any errors of which applicant may become aware in the specification.

Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 4. This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of

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the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to

consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g)

prior art under 35 U.S.C. 103(a).

5. Claim 45 is rejected under 35 U.S.C. 103(a) as being unpatentable over Lai et al. (US 6,267,649) in view of Yamasaki et al. (US 6,683,007).

Respect to claim 45, Lai discloses a fabrication method of a semiconductor device comprising the steps of:

forming a first conductive film (copper film) on a semiconductor wafer;

removing the first conductive film on and edge of the semiconductor wafer with a polishing means using a slurry (66) (col. 7 lines 15-45).

Lai fails to disclose the step of patterning the first conductive film (copper film) to form a wiring layer. In a semiconductor process, Yamasaki teaches to pattern the first conductive layer (42) to form the wirings (46) after the edge removal step (S4) (col. 14C-15E). It would have been obvious to one having ordinary skill in the art, at the time of invention, to modify Lai in view of Yamasaki by patterned the conductive layer to form wirings after the conductive film edge removal step because this technique help to create wirings which can act as interconnection layers in a semiconductor device.

6. Claim 46 is rejected under 35 U.S.C. 103(a) as being unpatentable over Lai in view of Uozumi (US 6,261,953) in view of Lai.

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Respect to claim 46, Uozumi discloses a fabrication method of a semiconductor device comprising the steps of:

forming a first conductive film (copper film) on a semiconductor wafer (step 3 in Fig 11);

patterning the first conductive film, thereby forming wirings (step 4 in Figure 11, col. 12 line 25-40)

removing the first conductive film (Cu film) on the bevel of the semiconductor wafer (step 6) (Figure 11, col. 12 lines 42-65, col. 13 lines 1-5; Note the semiconductor wafer "bevel" is equivalent or read on the limitation "an edge of semiconductor wafer").

Uozumi fail to teach that first conductive layer removal step on an edge of the wafer was performed with a polishing means using a slurry or an abrasive wheel. However, Uozumi clearly teaches to remove the first conductive layer on the edge of the wafer. Lai teaches to using a polishing means with a slurry (66) to remove conductive material (copper) on the edge of the wafer (col. 7 lines 35-67). It would have been obvious to one having ordinary skill in the art, at the time of invention, to modify Uozumi in view of Lai by using a polishing means with a slurry to remove the conductive film edge of the wafer because this technique will create desired edge profile and create edge control along the peripheral of the wafer.

Allowable Subject Matter

- 7. Claims 1-3, 33-44 are allowed.
- 8. The following is a statement of reasons for the indication of allowable subject matter: The cited prior arts fail to disclose or suggest either one of the following step in

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conjunction with all other limitation in the claims: removing or polishing the second insulative film on the edge of the semiconductor wafer in same sequential order as disclosed; or removing the first conductive film on the edge of the semiconductor wafer in same sequential order as disclosed; or removing the first insulative film on an edge of the semiconductor wafer in same sequential order as disclosed; or removing the third insulative film on an edge of the semiconductor wafer in same sequential order as disclosed.

Response to Arguments

9. Applicant's arguments with respect to claims 45-46 (previously cancelled claims 19-20) have been considered but are most in view of the new ground(s) of rejection.

Conclusion

10. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Binh X Tran whose telephone number is (571) 272-1469. The examiner can normally be reached on Monday-Thursday and every other Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine Norton can be reached on (571) 272-1465. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR.

Status information for unpublished applications is available through Private PAIR only.

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For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

BinhTran

Binh X. Tran